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#20/Response  
C. J. J. J.  
4/19/02

THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application Serial No. .... 09/420,835  
Filing Date ..... October 21, 1999  
Inventor ..... Werner Juengling  
Assignee ..... Micron Technology, Inc.  
Group Art Unit ..... 2812  
Examiner ..... H. Tsai  
Attorney's Docket No. .... MI22-1243  
Title: Semiconductor Processing Methods of Forming Devices on a Substrate,  
Forming Device Arrays on a Substrate, Forming Conductive Lines on a  
Substrate, and Forming Capacitor Arrays on a Substrate, and  
Integrated Circuitry

**RESPONSE TO DECEMBER 12, 2001 OFFICE ACTION**

To: Box Fee Amendment  
Assistant Commissioner for Patents  
Washington, D.C. 20231

From: Frederick M. Fliegel, Ph.D.  
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Responsive to the Office Action dated December 12, 2001, Applicant  
remarks as follows:

**AMENDMENTS**

There are no amendments to the specification or claims.